

Fig. 1A

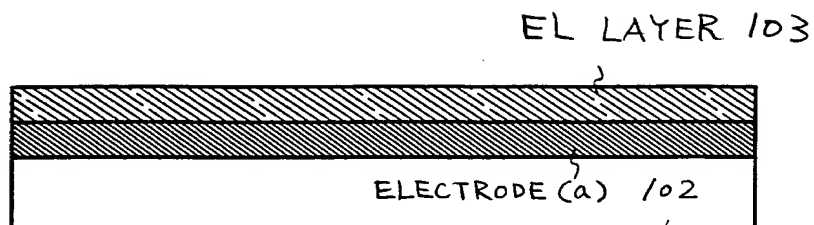


Fig. 1B, PLASMA PROCESSING STEP

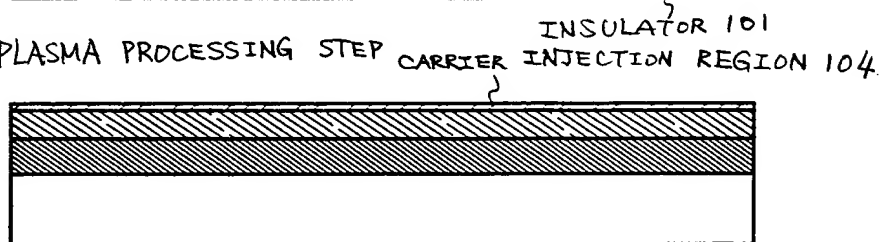


Fig. 1C

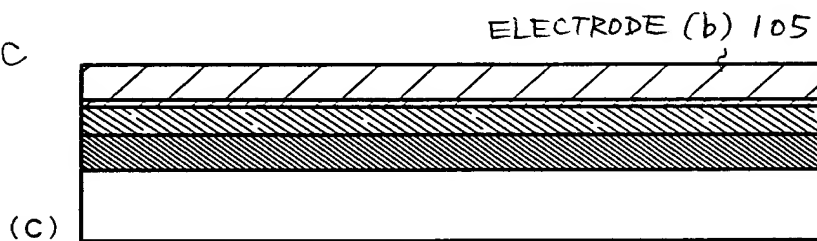


Fig. 1D

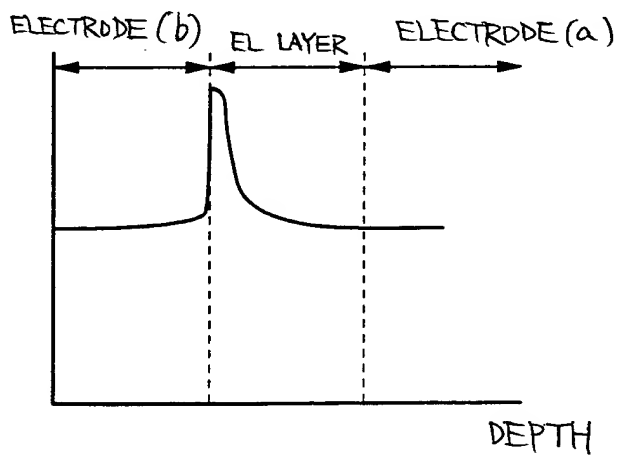
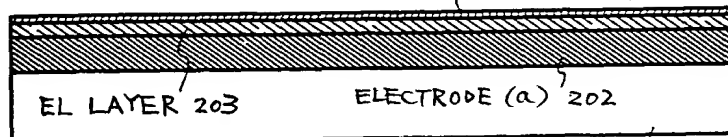


Fig. 2A PLASMA PROCESSING STEP CARRIER BLOCKING REGION (a) 204



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Fig. 2B PLASMA PROCESSING STEP CARRIER BLOCKING REGION (b) 205

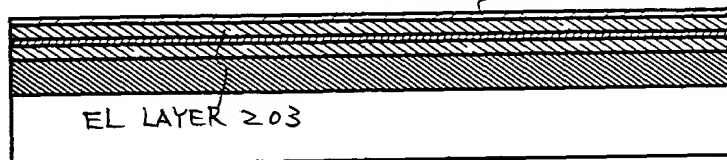


Fig. 2C

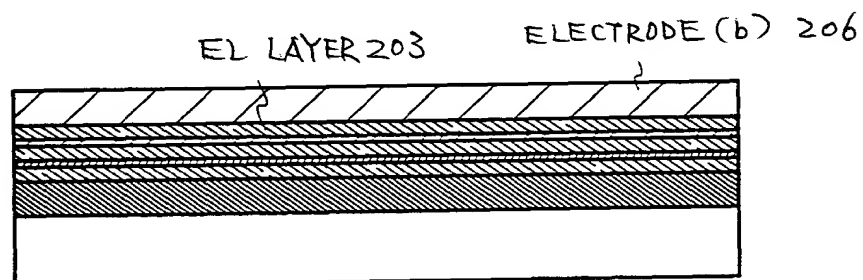


Fig. 3A

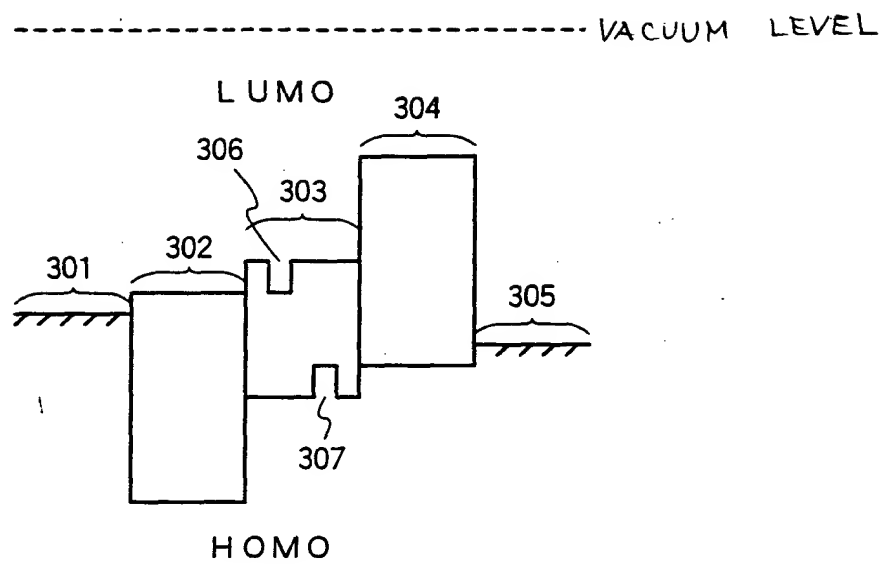
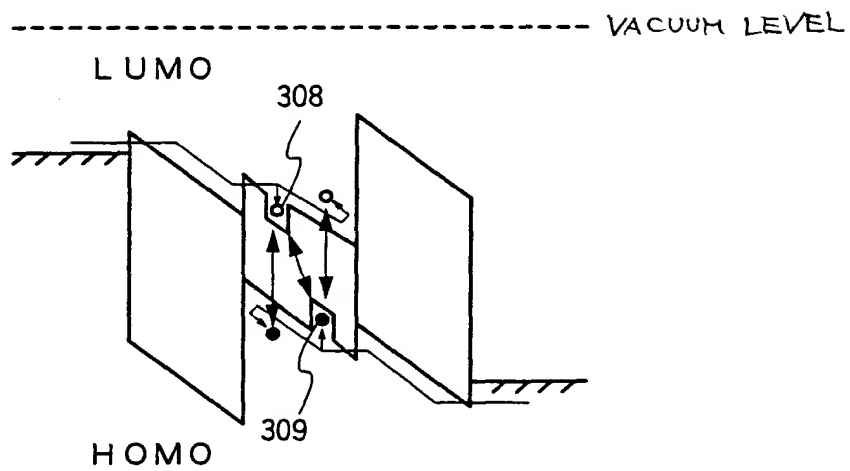


Fig. 3B





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Fig. 5A

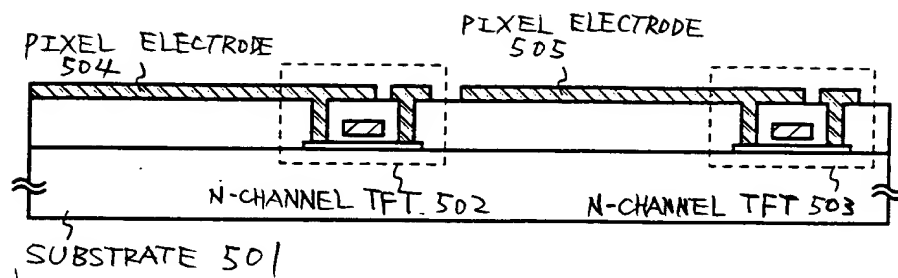


Fig. 5B

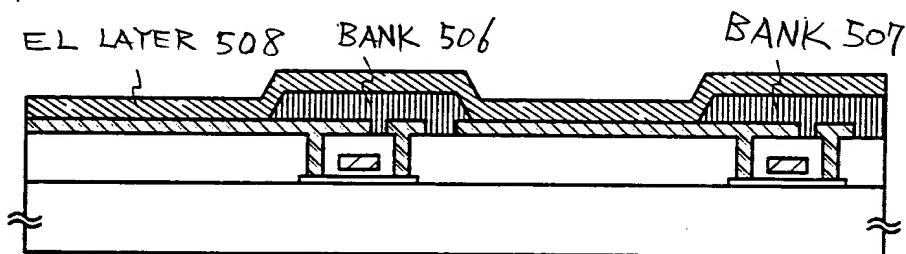


Fig. 5C

PLASMA PROCESSING STEP

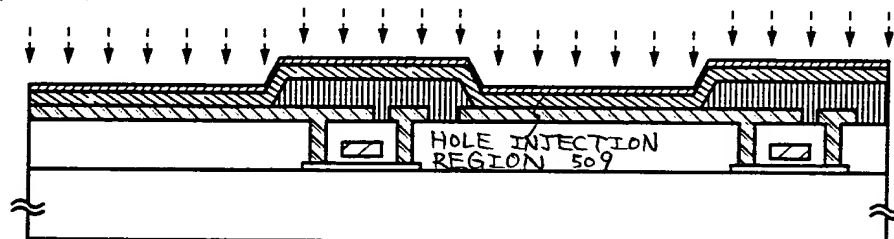


Fig. 5D

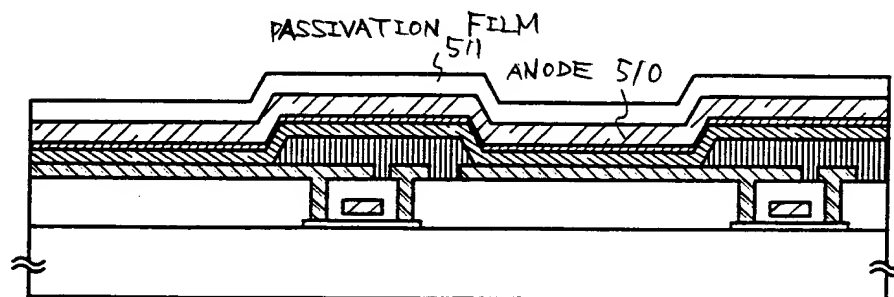


Fig. 6A

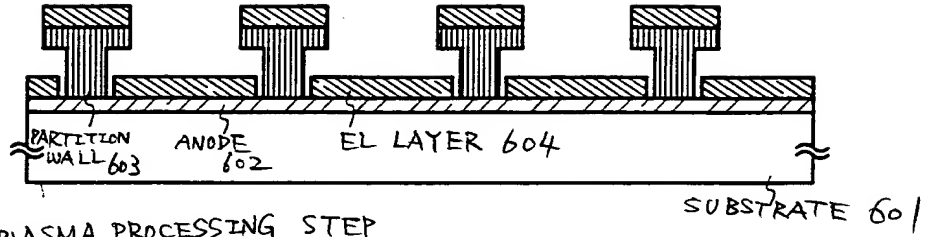


Fig. 6B PLASMA PROCESSING STEP

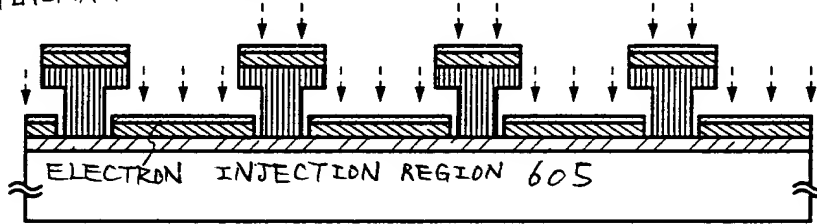
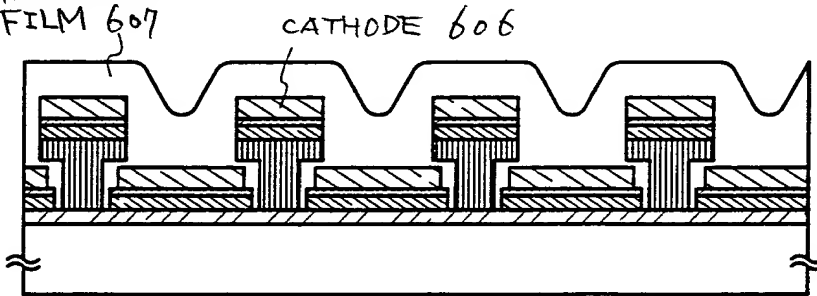


Fig. 6C PASSIVATION FILM 607



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Fig. 7A

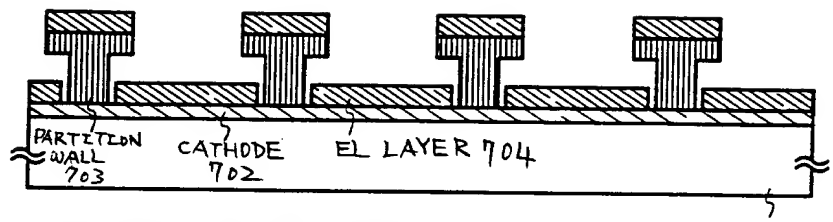


Fig. 7B PLASMA PROCESSING STEP

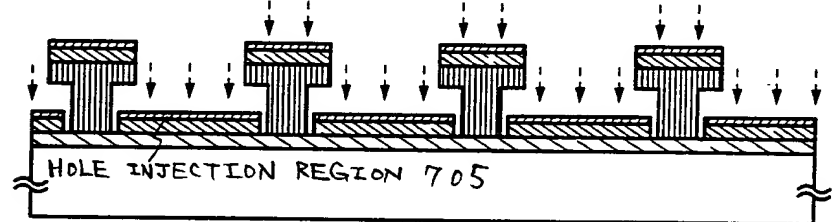
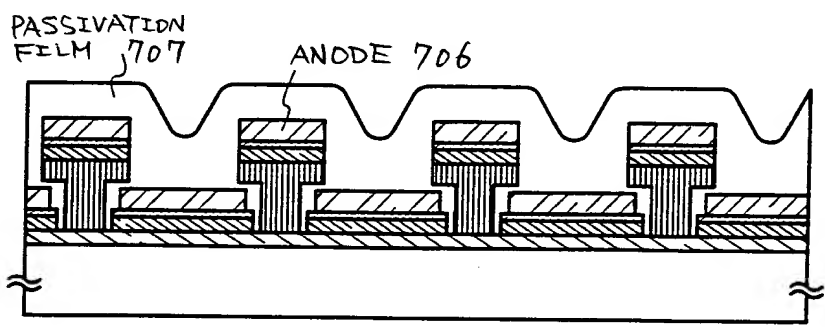


Fig. 7C



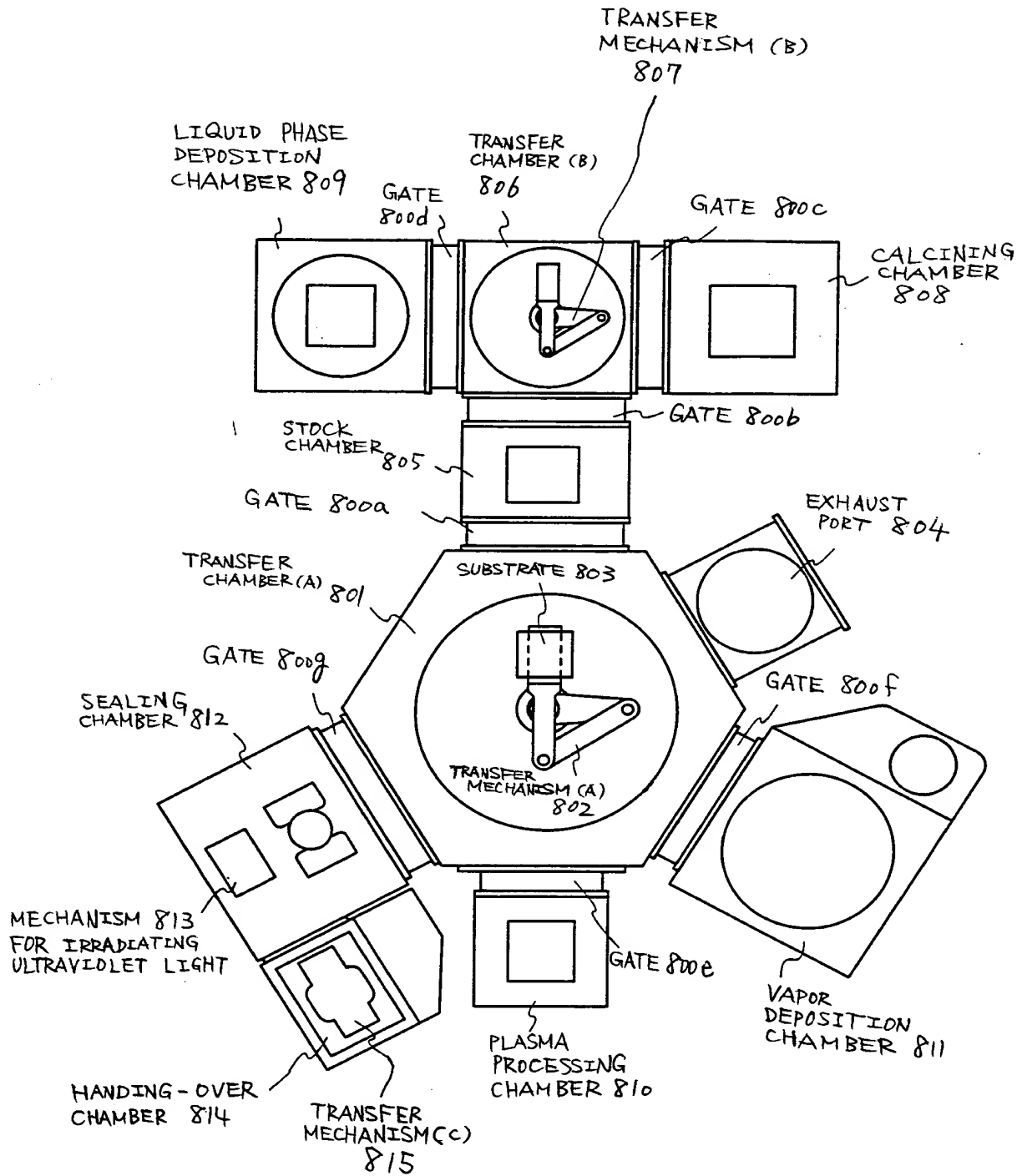


Fig. 8



Fig. 9A

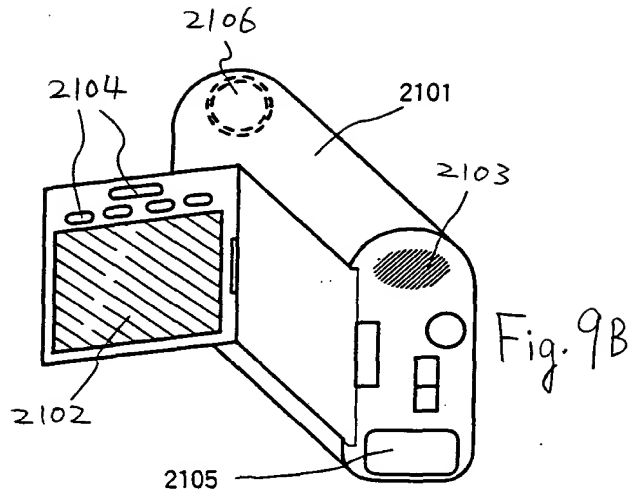
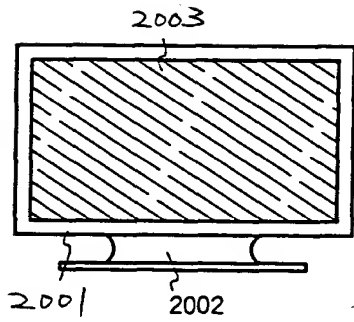


Fig. 9C

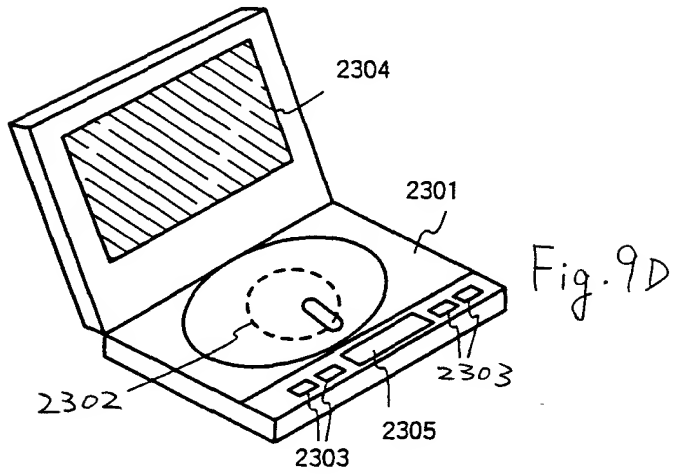
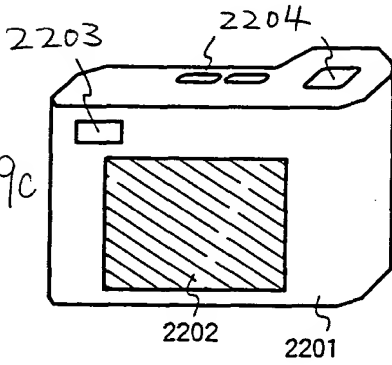
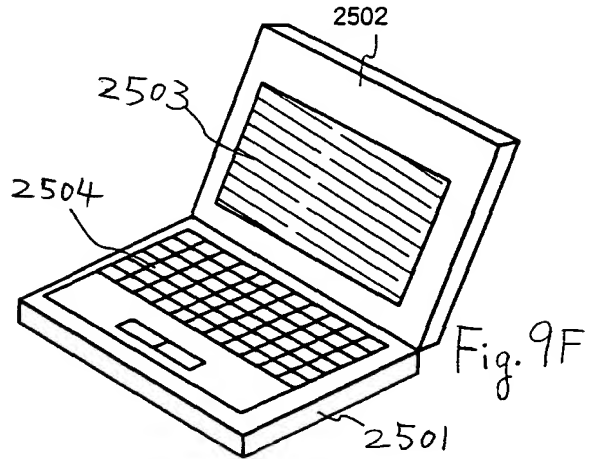
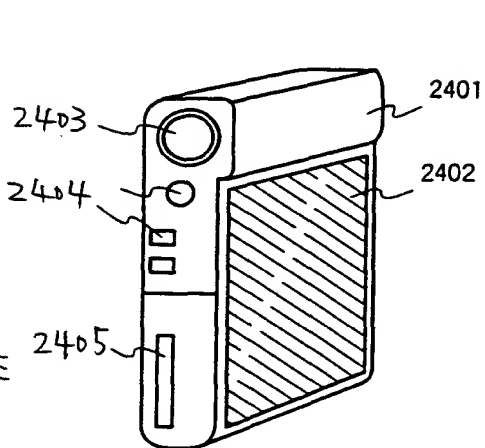


Fig. 9E



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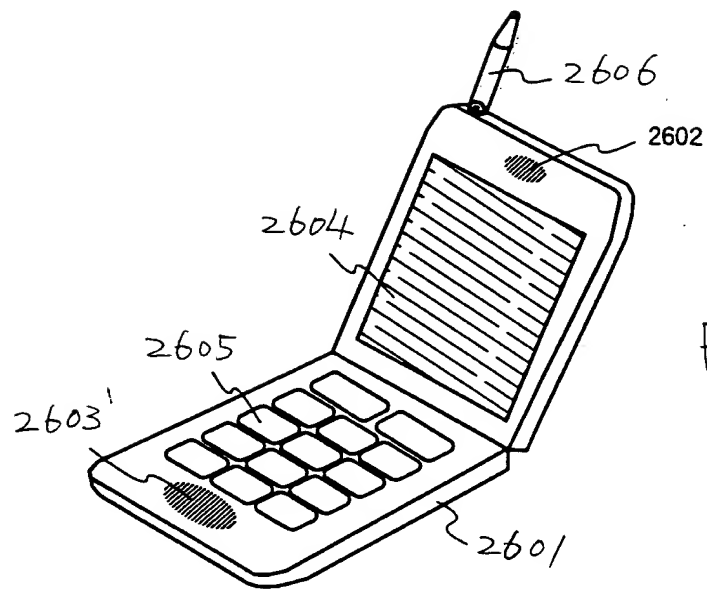


Fig. 10A

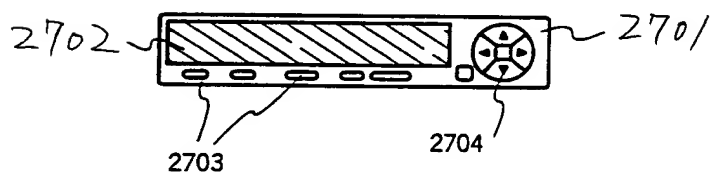


Fig. 10B